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TO THE HONORABLE DIRECTOR OF THE UNITED STATES PATENT AND TRADEMARK OFFICE. PLEASE RECORD THE ATTACHED ORIGINAL DOCUMENTS OR COPY THEREOF.

1. Name of conveying party:

Boxer Cross Inc.

Additional name(s) of conveying party(ies) attached?

☐ Yes

☒ No

2. Name and address of receiving party:

Name: Applied Materials, Inc.

Street Address: 2881 Scott Blvd.

City: Santa Clara, CA 95050

Country: USA

3. Nature of Conveyance:

☒ Assignment

☐ Merger

☐ Security Agreement

☐ Change of Name

☐ Other \_\_\_\_\_

Execution Date: January 5, 2005

Name and address of receiving party(ies):

Name:

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4. Application number(s) or patent number(s):

If this document is being filed together with a new application, the execution date of the application is:

A. Patent Application No.(s) – 10/722,724; 10/269,619; 10/090,316; 10/223,952; 10/884,673; 09/788,273; 10/090,262; 09/974,571; 10/090,287; 10/253,119; 10/977,380; 10/976,587; and 10/984,463

B. Patent No.(s)

Additional numbers attached?

☐ Yes

☒ No

5. Name and address of party to whom correspondence concerning document should be mailed:

Name: Omkar K. Suryadevara

Internal Address: Silicon Valley Patent Group LLP

Street Address: 2350 Mission College Boulevard, Suite 360

City Santa Clara State CA Zip 95054

6. Total number of applications and patents involved: 13

7. Total fee (37 CFR 3.41): \$520.00

☒

Enclosed

☒

Charge Deposit Account 50-2263 for any additional fees required for this conveyance and credit deposit account 50-2263 any amounts overpaid

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8. Statement and signature.

*To the best of my knowledge and belief, the foregoing information is true and correct and any attached copy is a true copy of the original document.*

Omkar K. Suryadevara 36,320

Name of Person Signing

S. Omkar  
Signature

March 30, 2005

Date

Total number of pages including cover sheet, attachments, and documents: 3

OP \$520.00 10722724

**ASSIGNMENT**

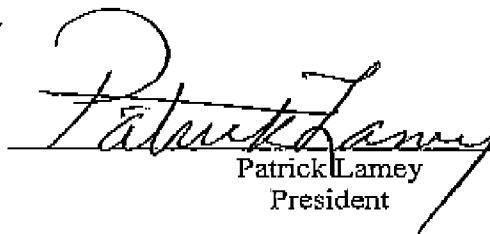
For good and valuable consideration, receipt of which is hereby acknowledged, Boxer Cross Inc., a Delaware corporation, having acquired by prior assignments, the entire right, title, and interest throughout the world in inventions for which United States Patent Applications listed below were filed, as well as any patent applications and patents of every country for said invention, including divisionals, reissues, continuations and extensions or foreign counterparts thereto, and all rights of priority resulting from the filing of said applications:

| US Application No. | Filing Date | US Patent Number | Title  |
|--------------------|-------------|------------------|--|
| 6/10/1998          | 09/095,805  | 6,054,868        | Apparatus And Method For Measuring A Property Of A Layer In a Multilayered Structure         |
| 11/25/2003         | 10/722,724  |                  | Apparatus And Method For Measuring A Property Of A Layer In a Multilayered Structure         |
| 6/10/1998          | 09/095,804  | 6,049,220        | Apparatus and Method for Evaluating a Wafer of Semiconductor Material                        |
| 4/6/2000           | 09/544,280  | 6,489,801        | Apparatus and Method for Evaluating a Wafer of Semiconductor Material                        |
| 10/11/2002         | 10/269,619  |                  | Apparatus and Method for Evaluating a Wafer of Semiconductor Material                        |
| 3/1/2002           | 10/090,316  |                  | Apparatus and Method For Measuring A Property Of A Layer In A Multilayered Structure         |
| 3/22/1999          | 09/274,821  | 6,323,951        | Apparatus And Method For Determining The Active Dopant Profile In A Semiconductor Wafer      |
| 8/21/2001          | 09/935,128  | 6,426,644        | Apparatus And Method For Determining The Active Dopant Profile In A Semiconductor Wafer      |
| 11/26/2001         | 09/994,441  | 6,483,594        | Apparatus And Method For Determining The Active Dopant Profile In A Semiconductor Wafer      |
| 8/19/2002          | 10/223,952  |                  | Apparatus And Method For Determining The Active Dopant Profile In A Semiconductor Wafer      |
| 7/2/2004           | 10/884,673  |                  | Apparatus And Method For Determining The Active Dopant Profile In A Semiconductor Wafer      |
| 3/8/2000           | 09/521,232  | 6,812,047        | Evaluating a Geometric or Material Property of a Multilayered Structure                      |
| 2/16/2001          | 09/788,273  |                  | Evaluating Sidewall Coverage In A Semiconductor Wafer  |
| 3/5/2001           | 09/799,481  | 6,812,717        | Use Of A Coefficient Of A Power Curve To Evaluate A Semiconductor Wafer                      |
| 3/1/2002           | 10/090,262  |                  | Evaluating A Multi-layered Structure For Voids   |
| 10/9/2001          | 09/974,571  |                  | Calibration As Well As Measurement On The Same Workpiece During Fabrication                  |
| 4/1/2002           | 10/090,287  |                  | Identifying Defects In A Conductive Structure Of A Wafer Based on Heat Transfer Therethrough |
| 9/23/2002          | 10/253,119  |                  | Measurement Of Lateral Diffusion Of Diffused Layers  |
| 10/29/2004         | 10/977,380  |                  | Evaluating a Property of a Multilayered Structure  |
| 10/29/2004         | 10/976,587  |                  | Use Of A Coefficient Of A Power Curve To Evaluate A Semiconductor Wafer                      |
| 11/8/2004          | 10/984,463  |                  | Evaluating A Multilayered Structure For Voids  |

hereby sells, assigns and transfers to Applied Materials Inc, a Delaware corporation, having a place at 2881 Scott Blvd, Santa Clara, CA 95050, its successors and assigns, the entire right, title and interest throughout the world in the above-identified patent applications as well as any patent applications and patents of every country for said inventions.

Executed this 5th day of January, 2005

For: Boxer Cross Inc

  
Patrick Lamey  
President

State of California

ss.  
County of Santa Clara

On January 5, 2005 before me, BARBARA HOLT, Notary Public  
personally appeared Patrick Lamey personally known to me or proved to me on the basis of  
satisfactory evidence to be the person whose name is subscribed to the within instrument and  
acknowledged to me that he executed the same in his authorized capacity, and that by his signature on  
the instrument the person, or the entity upon behalf of which the person acted, executed the  
instrument.

WITNESS my hand and official seal.

  
SIGNATURE OF NOTARY

